

L Number	Hits	Search Text	DB	Time stamp
1	204	plot\$6 same cut\$6 same sensor	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/10/31 16:08
2	6	(plot\$6 same cut\$6 same sensor) same master	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/10/31 16:07
3	1430089	plot\$6 same cut\$6 same master same substrate semiconductor	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/10/31 16:17
4	13392	(plot\$6 same cut\$6 same master same substrate semiconductor) same tft	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/10/31 16:15
5	561	((plot\$6 same cut\$6 same master same substrate semiconductor) same tft) same (image with sensor)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/10/31 16:16
6	514	((plot\$6 same cut\$6 same master same substrate semiconductor) same tft) same (image adj sensor)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/10/31 16:17
7	0	plot\$6 same cut\$6 same (master ADJ substrate) same semiconductor	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/10/31 16:18
8	1	plot\$6 same cut\$6 same (master with substrate) same semiconductor	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/10/31 16:19
9	1	plot\$6 same cut\$6 same (master with substrate) same tft	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/10/31 16:20
10	2	cut\$6 same (master with substrate) same tft	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/10/31 16:26
11	38	cut\$6 same (master with substrate) same semiconductor	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/10/31 16:26
12	1	(cut\$6 same (master with substrate) same semiconductor) and tft	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/10/31 16:27
13	0	(cut\$6 same (master with substrate) same semiconductor) and lcd	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/10/31 16:27
14	19	(cut\$6 same (master with substrate) same semiconductor) and (liquid adj crystal)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2004/10/31 16:28

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